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Dry Etching (Page 1 of 2): Plasma Etching

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**Inventor Name Search Result**

Your Search was:

Last Name = OH

First Name = JAE-JOON

Application#	Patent#	Status	Date Filed	Title	Inventor Name
09995421	Not Issued	71	11/27/2001	Methods, apparatus and computer program products for simulating plasma behavior in a plasma reactor apparatus using two-dimensional cross-section computations	OH, JAE-JOON
10449777	6806437	150	06/02/2003	INDUCTIVELY COUPLED PLASMA GENERATING APPARATUS INCORPORATING DOUBLE-LAYERED COIL ANTENNA	OH, JAE-JOON
10844804	Not Issued	93	05/13/2004	ELEMENTARY PLASMA SOURCE AND PLASMA GENERATION APPARATUS USING THE SAME	OH, JAE-JOON
10909467	Not Issued	71	08/02/2004	Apparatus for generating inductively-coupled plasma and antenna coil structure thereof for generating inductive electric fields	OH, JAE-JOON
10969928	Not Issued	30	10/22/2004	Antenna for use in producing plasma and plasma processing apparatus comprising the same	OH, JAE-JOON
11007878	Not Issued	30	12/09/2004	Electron cyclotron resonance equipment with variable flare angle of horn antenna	OH, JAE-JOON

Inventor Search Completed: No Records to Display.

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OH JAE-JOON Search

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 PALM INTRANETDay : Friday
Date: 5/19/2006
Time: 15:27:45**Inventor Name Search Result**

Your Search was:

Last Name = KIM

First Name = TAI-KYUNG

Application#	Patent#	Status	Date Filed	Title	Inventor Name
09995421	Not Issued	71	11/27/2001	Methods, apparatus and computer program products for simulating plasma behavior in a plasma reactor apparatus using two-dimensional cross-section computations	KIM, TAI-KYUNG
11017594	7042001	150	12/20/2004	PHASE CHANGE MEMORY DEVICES INCLUDING MEMORY ELEMENTS HAVING VARIABLE CROSS-SECTIONAL AREAS	KIM, TAI-KYUNG
11028202	Not Issued	30	01/04/2005	Phase-change memory device and method of manufacturing the same	KIM, TAI-KYUNG
11227511	Not Issued	30	09/15/2005	Ion implanters having an arc chamber that affects ion current density	KIM, TAI-KYUNG

Inventor Search Completed: No Records to Display.

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Inventor Name Search Result

Your Search was:

Last Name = CHUNG

First Name = WON-YOUNG

Application#	Patent#	Status	Date Filed	Title	Inventor Name
07739165	5116223	150	08/01/1991	SWING ARM FOR SUPPORT OF DENTIST'S SUCTION PUMP NOZZLE	CHUNG, WON-YOUNG
09995421	Not Issued	71	11/27/2001	Methods, apparatus and computer program products for simulating plasma behavior in a plasma reactor apparatus using two-dimensional cross-section computations	CHUNG, WON-YOUNG
10956567	Not Issued	30	10/01/2004	Color-converting light emitting device including fluorescent powder having large grain diameter, method of producing the same, and resin composition used therein	CHUNG, WON-YOUNG
10983023	Not Issued	61	11/05/2004	Method and apparatus for drying a wafer, and an apparatus for cleaning and drying a wafer	CHUNG, WON-YOUNG
11017594	7042001	150	12/20/2004	PHASE CHANGE MEMORY DEVICES INCLUDING MEMORY ELEMENTS HAVING VARIABLE CROSS-SECTIONAL AREAS	CHUNG, WON-YOUNG
11028202	Not Issued	30	01/04/2005	Phase-change memory device and method of manufacturing the same	CHUNG, WON-YOUNG
11227511	Not Issued	30	09/15/2005	Ion implanters having an arc chamber that affects ion current density	CHUNG, WON-YOUNG

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Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	564	((216/71) or (216/72) or (216/68)).CCLS.	USPAT; USOCR	OR	OFF	2006/05/19 18:31
L2	20	l1 and plasma near2 character\$4	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/05/19 18:31
S1	180	(703/9).CCLS.	USPAT; USOCR	OR	OFF	2006/05/19 10:03
S2	9	S1 and plasma	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/03/21 09:22
S3	4	plasma near2 character\$6 same plurality adj3 section\$2	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/03/21 09:24
S4	48	(plasma near2 character\$6) and (plurality adj3 section\$2)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/03/21 09:25
S5	4	(plasma near2 character\$6) and (plurality adj3 section\$2) and chamber and magnets	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/03/21 09:25
S6	2	((("60009255") or ("5590051") or ("5421934"))).PN.	USPAT; USOCR	OR	OFF	2006/05/19 10:03
S7	3	((("60009255") or ("5590051") or ("5421934"))).PN.	USPAT; USOCR	OR	OFF	2006/05/19 11:24
S8	3	((("6014943") or ("5801971") or ("6199029"))).PN.	USPAT; USOCR	OR	OFF	2006/05/19 12:59
S9	58	plasma and character\$5 and (plurality near cross\$section\$2)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/05/19 13:01
S10	0	plasma near character\$5 and (plurality near cross\$section\$2)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/05/19 13:01
S11	1	plasma and character\$5 and (plurality near cross\$section\$2) and species and monte	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/05/19 13:01

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S12	9039	plasma and (two\$dimension\$3) and (cross\$section\$3 or etch\$3)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/05/19 15:37
S13	648	plasma same (two\$dimension\$3) and (cross\$section\$3 or etch\$3)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/05/19 15:37
S14	177	plasma same (two\$dimension\$3) same (cross\$section\$3 or etch\$3)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/05/19 15:37
S15	2	plasma same (two\$dimension\$3) same (cross\$section\$3 or etch\$3) and poisson	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/05/19 15:38
S16	379	plasma same (cross\$section\$3 or etch\$3) and poisson	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/05/19 15:38
S17	9	plasma same (cross\$section\$3 or etch\$3) same poisson	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/05/19 15:38